

1F 4191

Dkt. 2710/74074



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Masanori OGAWA et al.

Serial No. : 10/528,393

Group Art Unit 4191

Filed : March 18, 2005

Examiner Christopher S. Nichols

For : METHOD FOR PRODUCING
RESIN MASKING MATERIAL

AMENDMENT

1185 Avenue of the Americas
New York, NY 10036
June 19, 2008

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action dated March 25, 2008, please amend the above-identified application as follows:

Amendments to the claims are reflected in the Listing of Claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.